

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

SERIAL NO.: 10/055,320

ART UNIT: 2812

APPLICANT: Bassom and Mai

EXAMINER: Not assigned

FILING DATE: 01/23/2002

TITLE: Fabrication of High Resistivity Structures Using Focused Ion Beams

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
 Washington, D.C. 20231

Prior to examination, please amend the application as follows:

In the specifications:

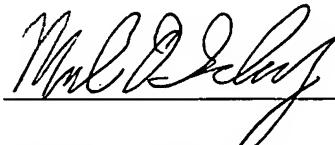
On page 1, after the title and before "Technical Field of the Invention", insert the following paragraph:

Q1 -- This application claims priority from U.S. Provisional Patent Application No: 60/264,472, filed January 26, 2001.--

Remarks

Applicants insert into the specifications an indication of the priory which was claimed in the declaration.

Respectfully submitted,



Michael O. Scheinberg
 Patent Reg. 36,919
 P.O. Box 164140
 Austin, Texas 78716-4140
 Telephone: (512) 328-9510
 Facsimile: (512) 306-1963

Date: 3/21/02

CERTIFICATE OF MAILING

I hereby certify that this paper or fee is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the 21th day of March, 2002

By: Kathleen Scheinberg
 Name: Kathleen Scheinberg